

OFFICIAL

OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Davlin et al.
 Serial No. : 09/651,498
 Filed : August 30, 2000
 Title : TEMPERATURE CONTROL ELEMENTS, SPINDLE ASSEMBLY, AND
 WAFER PROCESSING ASSEMBLY INCORPORATING SAME
 Docket No. : MIO 0071 PA
 Examiner : Ram N. Kackar
 Art Unit : 1763
 Confirm. No. : 1401

Assistant Commissioner for Patents
 Washington, D.C. 20231

FEB 18 2003
 218/03
 m/w
 CERTIFICATE OF FACSIMILE TRANSMISSION
 I hereby certify that this paper is being facsimile transmitted to the Patent and
 Trademark Office (703) 872-9311 on February 6, 2003.

Joan N. Williams
Joan N. Williams

Reg. No. 52,364

Sir:

AMENDMENT AFTER FINAL REJECTION

This paper is being filed in response to the Office Action mailed January 6, 2003.
 Reconsideration is respectfully requested in light of the amendments and remarks below. Entry
 of this amendment is requested as it is believed to place the application in condition for
 allowance.

IN THE CLAIMS

The entire set of presently pending claims is reproduced below for the convenience of the
 Examiner. Amended and cancelled claims are indicated as such in the parenthetical following
 the claim number.

Please cancel claims 1-5, 9-12, and 21-32.

1-5. (Cancelled)

9-12. (Cancelled)

15. A rotary spindle assembly comprising:

GROUP 1700
 FEB 07 2003
 FX RECEIVED